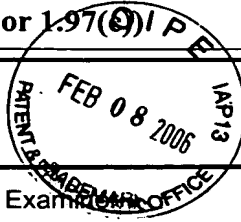


TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SEC.898D

In Re Application Of: Woo-Chan Jung et al.



| Application No. | Filing Date | Examiner | Customer No. | Group Art Unit | Confirmation No. |
|-----------------|-------------|---------------|--------------|----------------|------------------|
| 10/673,937 | 09/30/2003 | Ida M. Soward | 20987 | 2811 | 1631 |

Title: **METHOD OF MANUFACTURING INSULATING LAYER AND SEMICONDUCTOR DEVICE INCLUDING INSULATING LAYER, AND SEMICONDUCTOR DEVICE FORMED THEREBY**

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

37 CFR 1.97(b)

1. ☐ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. ☒ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☒ the statement specified in 37 CFR 1.97(e);

OR

☐ the fee set forth in 37 CFR 1.17(p).

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

(Under 37 CFR 1.97(b) of 37 CFR 1.97(e))

Docket No.
SEC.898D

In Re Application of: Woo-Chan Jung et al.

FEB 08 2006
PATENT TRIAGE OFFICE

Application No.

10/673,937

Filing Date

09/30/2003

Ida M. Soward

Customer No.

20987

Group Art Unit

2811

Confirmation No.

1631

Title: **METHOD OF MANUFACTURING INSULATING LAYER AND SEMICONDUCTOR DEVICE INCLUDING INSULATING LAYER, AND SEMICONDUCTOR DEVICE FORMED THEREBY****Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below.
- ☐ Charge the amount of _____
- ☐ Credit any overpayment.
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- ☐ Payment by credit card. Form PTO-2038 is attached.

WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**Certificate of Transmission by Facsimile***

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***This certificate may only be used if paying by deposit account.**Dated: **FEBRUARY 8, 2006**ADAM C. VOLENTINE
REG. NO. 33289VOLENTINE FRANCO & WHITT, PLLC
11951 FREEDOM DRIVE, SUITE 1260
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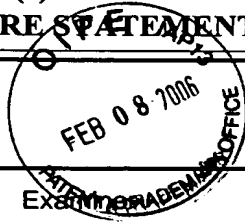
TEL. 571.283.0720

cc:

**STATEMENT UNDER 37 CFR 1.97(e) ACCOMPANYING
INFORMATION DISCLOSURE STATEMENT**

Docket No.
SEC.898D

In Re Application Of: **Woo-Chan Jung et al.**



| Application No. | Filing Date | Examiner | Customer No. | Group Art Unit | Confirmation No. |
|-----------------|-------------|---------------|--------------|----------------|------------------|
| 10/673,937 | 09/30/2003 | Ida M. Soward | 20987 | 2811 | 1631 |

Invention: **METHOD OF MANUFACTURING INSULATING LAYER AND SEMICONDUCTOR DEVICE
INCLUDING LINSULATING LAYER, AND SEMICONDUCTOR DEVICE FORMED THEREBY**

COMMISSIONER FOR PATENTS:

This is a statement under the provisions of 37 CFR 1.97(e) in the above-identified application.

Check applicable statement herebelow:

Statement Under 37 CFR 1.97(e)(1)

- ☒ Each item of information contained in the accompanying Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

Statement Under 37 CFR 1.97(e)(2)

- ☐ No item of information contained in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned person, after making reasonable inquiry, no item of information contained in the accompanying Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.

Signature

**ADAM C. VOLENTINE
REG. NO. 33289**

**VOLENTINE FRANCOS & WHITT, PLLC
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RESTON VA 20190**

TEL. 571.283.0720

CC:

Dated: **FEBRUARY 7, 2006**

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

| | |
|------------------------|----------------------|
| Application Number | 10/673,937 |
| Filing Date | 09/30/2003 |
| First Named Inventor | Woo-Chan Jung et al. |
| Art Unit | 2811 |
| Examiner Name | Ida M. Soward |
| Attorney Docket Number | SEC.898D |

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| Sheet | 1 | of | 1 |
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U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

| FOREIGN PATENT DOCUMENTS | | | | | | |
|--------------------------|--------------------------|---|---------------------|--|---|----------------|
| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | Publication Date | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear | T ⁶ |
| | | Country Code*~Number*~Kind Code* (if known) | MM-DD-YYYY | | | |
| | F | EP 1 033 747 A2 | 09/06/2000 | Applied Materials, Inc. | | ✓ |
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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